

Appl. No. 10/707,175
Amdt. Dated 08/03/2005
Reply to Office action of 05/03/05

Amendments to the Specification:

On page 1 and on the abstract (last) page

Change the title from

"ULTRA-THIN SILICIDATION-STOP EXTENSIONS IN MOSFET DEVICES"

to --

Method Of Forming Ultra-Thin Silicidation-Stop Extensions In MOSFET Devices

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